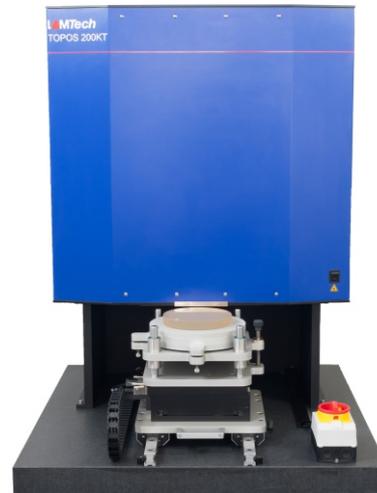


TOPOS

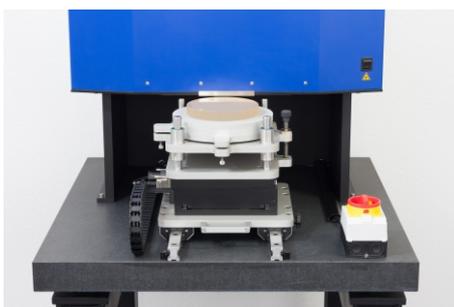
Flatness Measurement of Large Rings and Surfaces



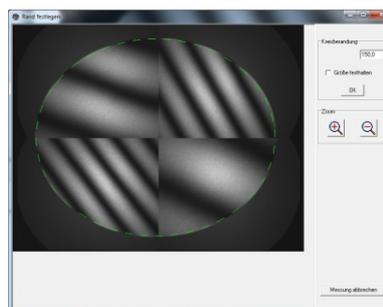
For rings with large diameters (such as mechanical seals) the relationship of the diameter to the width of the bearing surface is usually very unfavourable for a precise flatness check. Recognising and quantifying waviness on the thin rings from the light bands with an optical flat is very difficult, if not impossible. Even the use of an interferometer with a large measuring field and an automated

interferogram evaluation is frequently problematic. The limited spatial resolution of the camera only allows for a small number of measuring points across the ring width. Thus, smaller errors can no longer be recognised or more uneven parts can not be measured. The **solution** to this problem is the measurement of the ring in individual, consecutive, overlapping segments by the

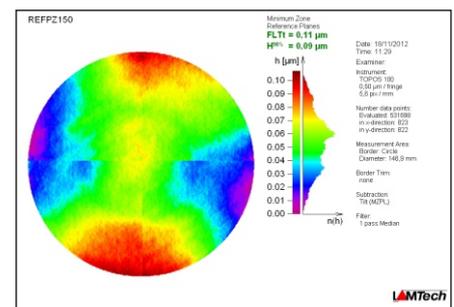
help of a rotary table for large rings and a cross table for large surfaces. Using the overlapping regions, it is possible to merge the individual segments computationally to obtain the entire surface at a high accuracy. The measurement with a high local resolution also allows the visibility of fine structures. The procedure distinguishes itself by a high economic efficiency.



Placing the part on the cross table



Composite interferogram after a measurement



Flatness as false colour picture

The TOPOS Interferometers are based on a non contact measurement principal. This is the basis for a measurement with a cross or rotary table. Thus, there is no limit to the size of the measurable piece in reference to the measuring field of the interferometer.

The measurement of large rings is based on the measurement of overlapping ring segments, which are then stitched computationally to an entire ring. The rotation under the measuring field of the

TOPOS 100 results from a precision rotary table. With this rotary table an outer diameter of 420 mm with a maximum ring width of 80 mm can be measured.

Rings with larger ring widths as well as large surfaces will be measured by the use of a cross table. The test object will be shifted beneath the measuring field in a way that each segment of the piece will be recorded with an overlapping. Again, the segments will be stitched computationally to an entire surface.

Both processes of the whole measurement procedure are fully automated. The number of the individual measurements depend on the size of the piece. After the measurement of all segments, the flatness of the entire piece will be shown to the user, like in the case of a single measurement

TOPOS 100 interferometers can be reconditioned with a cross or rotary table, if the range of pieces expands towards larger rings or surfaces.

Models	Measurement area
TOPOS 200 KT	Measurement of surfaces with a maximum outer diameter of 190 mm, squared up to 170 mm
TOPOS 300 KT	Measurement of surfaces with a maximum outer diameter of 290 mm, squared up to 270 mm
TOPOS DT	Measurement of rings with an outer diameter up to 420 mm



Lamtech Lasermesstechnik GmbH
 Nellinger Straße 20
 D-70619 Stuttgart
 Germany

T: +49 | (0)711 | 232810
 F: +49 | (0)711 | 2361125
www.lamtech.de
info@lamtech.de